



AFW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of: Takahiro  
Arakida

Application No. 10/826,085

Filed: April 16, 2004

For: MULTIPLE WAVELENGTH  
SEMICONDUCTOR LASER AND  
MANUFACTURING METHOD THEREOF

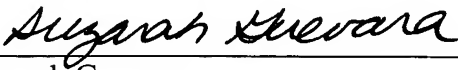
Group Art Unit: 2828

Examiner: To be assigned

**CERTIFICATE OF MAILING**

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Suzarah Guevara

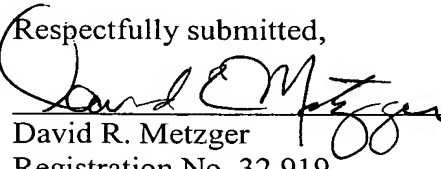
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Alexandria, VA 22313-1450

**STATUS INQUIRY**

Sir:

With regard to the above-identified patent application that was filed in the U.S. Patent and Trademark Office on April 16, 2004, U.S. Serial No. 10/826,085, we have not yet received any communication from the U.S. Patent Office since issuance of the Notice of Publication of Application which was dated November 25, 2004. At this time, we respectfully request the current status of this application.

Dated: December 2, 2005

Respectfully submitted,  
  
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